



PATENT 8075-1015

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Rikizo HATAKEYAMA et al.

Application No. 10/552,709

Filed October 7, 2005

METHOD AND APPARATUS FOR PRODUCING GAS ATOM CONTAINING FULLERENE, AND GAS ATOM CONTAINING FULLERENE

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 2, 2005

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying document, copy of which is attached to this statement, is made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of this item is that this reference was discovered during any searches they or their client had made, or that they were considered in the preparation of the application.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION			Attorney Docket No.: 8075-1015		Application No.: 10/552,709		
	IN AN APPLICA	TION	Applicant: Rikizo HATAKEYAMA et al.				
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	Akihiko FUJII et al., Endohedral Metallof 2255.	"Photocurrent Enhar ullerene La@C ₈₂ ," J _l	ncement in Conducting Poly pn. J. Appl. Phys., Vol. 41,	mer Devident	ce by Dopin 4A, (2002),	g with pp. 225	54-
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

* Abstract provided for the Examiner's convenience